

Goal of the DRD3 collaboration



The DRD3 collaboration has the dual purpose of pursuing the realization of the strategic developments outlined by the Task Force 3 (TF3) in the ECFA roadmap [1] and promoting blue-sky R&D in the field of solid-state detectors.

Presently, the DRD3 proto-collaboration comprises about 100 groups, 75% from Europe

DRDT 3.1	DRDT 3.2
CMOS sensors	Sensors for 4D-tracking
DRDT 3.3	DRDT 3.4
Sensors for extreme fluences	A demonstrator of 3D-integration

Table 1: The four strategic DRDTs of DRD3



DRD3 Timeline



Q4-2022/Q1-2023

- Formation of the DRD3 proposal team
- Collection of interest from the institutes
- Preparation of the workshop and shaping the direction of RD.

Q2-2023

- Writing the scientific proposal (~20 pages) that includes conclusions/feedback from the workshop and questionnaires
- Second questionnaire to collect the interest of the participant in specific topics

Q3-2023

- Analysis of the questionnaires
- Submission of the proposal:
- DRDC review (scientific, milestones, feasibility, financials)
- DRDC not yet established, it might lead to delay

Q4-2023

- Establishing continuation of existing RD50 projects and carrying resources.
- Follow the review revisions and upon green light from DRDC, CERN research board approves the formation of the collaboration



Future Steps - snakes and ladders



Now

Finish the document

~2 weeks Send the document along with the second questionnaire ~2 months

Final version of the document

DRDC approval

DRD3 Collaboration
Board, CB chair
election

Selection of candidate
Spokespersons

DRD3 first meeting and Spokespersons election

2024

Election of Working Group leaders

2024

Preparation of the MOU







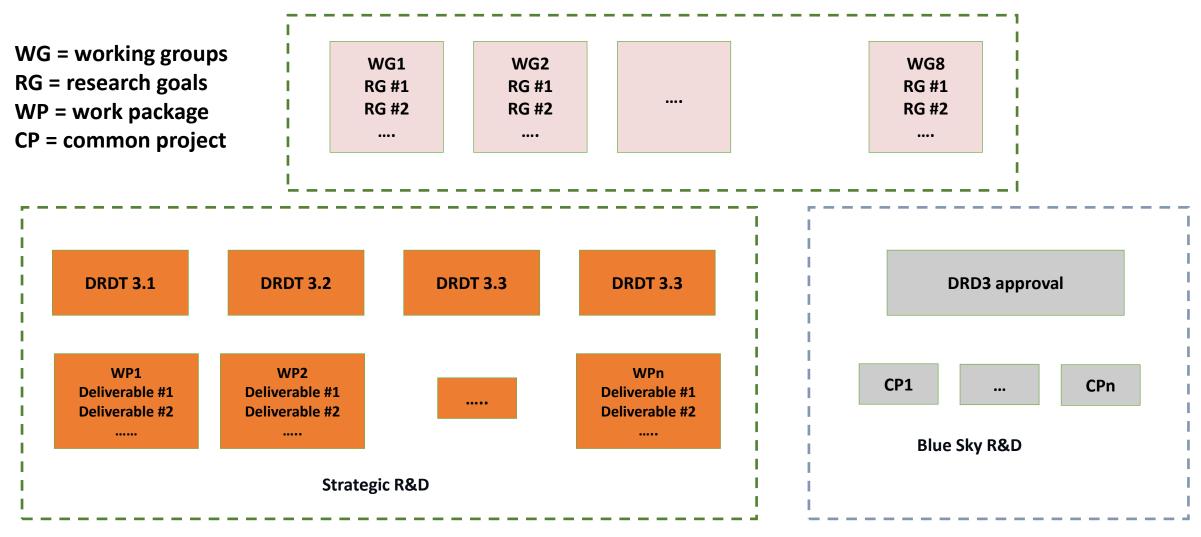
DRD3 scientific structure: working groups **DRD3**

WG 1 Monolithic CMOS sensors	WG 2 Sensors for tracking and Calorimetry with space/time and/or energy resolution	WG 3 Radiation damage and ultra high fluences	WG 4 Simulations	WG 5 New Characterization Methods, Techniques and Infrastructures	WG 6 Non-silicon semiconductor and other material studies	WG 7 Interconnect and device Fabrication technologies	WG 8 Dissemination and outreach
 Investigate Monolithic Active Pixel Sensors (MAPS) than may achieve very high spatial resolution and very low mass. Understand radiation hardness limits of MAPS. Investigate the use of State-of-the-art commercial CMOS in tracking and vertex detectors. Explore the use of passive CMOS as a complement to standard sensors. 	sensors, with and without	 Undestrand microscopic properties of detectors at extreme fluences. Understand the limit of semiconductors at high fluences. Study innovative materials Charachterization of defects in semiconductors 	 Verify and prepare the TCAD tools for use in various DRDTs Improve and develop MC tools Develop and implement new radiation hardness models and device parametrizations Design common tools for data processing (digitization, electronics) 	 Explore the use of new techniques to characterize detectors Develop common DAQ tools Irradiation facilities, including extreme fluences. Test beams IBIC studies 	 Understand the detailes of the damage of the WBG semicondcuntos Develop methods for characterization and fabrication of detectors from innovative materials 	 Advanced Integration Technologies. Process capabilities for different wafer sizes and sensor material types. Alternative bonding technologies for ultra-thin wafers. Reduction of interconnection pitches 	 Participation in congress Explore other applications (Nuclear physics, Astrophysics, Fusion) Contact industrial partners. Participation in EU or similar funding projects Website



DRD3 general structure









Document



DRD3 - Solid State Detectors - Research Proposal -
DRD3 Proposal Team
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It exists, but it is not ready for distribution yet



